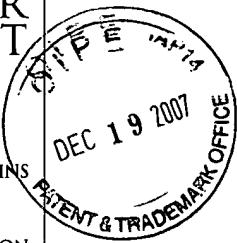


ZFW

JENKINS
WILSON
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& HUNT

patent attorneys
December 17, 2007



I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on December 17, 2007.

Laura J. Pleasant
Date of Signature

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P.O. Box 1450
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Re: U.S. Patent Application Serial No. 10/615,842 for
DEPOSITION METHOD FOR NANOSTRUCTURE
MATERIALS
Our Ref. No. 421/170/8/2 CIP

Sir:

Please find enclosed in connection with the subject U.S. patent application the following documents:

1. Supplemental Information Disclosure Statement (2 pages);
2. Form PTO-1449 (1 pages);
3. Copies of cited references (2 references);
4. A return-receipt postcard to be returned to us with the U.S. Patent and Trademark Office filing stamp thereon; and

Please contact our offices if there are any questions with this matter.

Respectfully submitted,

JENKINS, WILSON, TAYLOR & HUNT, P.A.

Jeffrey L. Wilson
Registration No. 36,058
Customer No: 25297

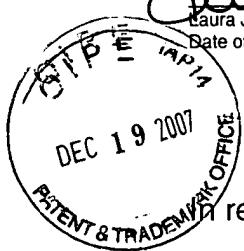
Enclosures

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December 17, 2007



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of: Oh et al.

Group Art Unit: 1753

Serial No.: 10/615,842

Examiner: Phasge, Arun S.

Filed: July 10, 2003

Docket No.: 421/170/8/2 CIP

Confirmation No.: 9995

For: DEPOSITION METHOD FOR NANOSTRUCTURE MATERIALS

* * * * *

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F.R. 1.56, 1.97, and 1.98, applicants' undersigned attorney brings to the attention of the Patent and Trademark Office the documents listed on the attached Form PTO-1449. Copies of the references as well as Form PTO-1449 are attached hereto. This is not to be construed as a representation that a search has been made or that a reference is relevant merely because cited.

No fee under 37 C.F.R. Section 1.17(p) is due as the undersigned hereby certifies that each item of information contained in this statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

Serial No.: 10/615,842

Early passage of the subject application to issue is earnestly solicited.

Although it is believed that no fee is due, the Commissioner is hereby authorized to charge any fees associated with the filing of this Information Disclosure Statement to Deposit Account No. **50-0426**.

Respectfully submitted,

JENKINS, WILSON, TAYLOR & HUNT, P.A.

Date: December 17, 2007

By:



Jeffrey L. Wilson
Registration No. 36,058
Customer No: 25297

Enclosures